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INFORMATION DISCLOSURE STATEMENT

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Applicant: Takayuki IKEDA et al.

Filing Date: April 4, 2000

Group:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
A.S.	5,594,569	01/14/97	Konuma et al			

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation Yes No
A.S.	7-321339	12/08/95	Japan			Abstract
↓	7-326767	12/12/95	Japan			Abstract
↓	9-312260	12/02/97	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Shimokawa et al., "Characterization of High-Efficiency Cast-Si Solar Cell Wafers by MBIC Measurement", Japanese Journal of Applied Physics, Vol. 27, No. 5, May 1988, pp. 751-758
	Furue et al., "P-78: Characteristics and Driving Scheme of Polymer-Stabilized Monostable FLCSD Exhibiting Fast Response Time and High Contrast Ratio with Gray-Scale Capability", SID 98 Digest, ©1998, pp. 782-785
	Yoshida et al., "33.2: A Full-Color Thresholdless Antiferroelectric LCD Exhibiting Wide Viewing Angle with Fast Response Time", SID 97 Digest, ©1997, pp. 841-844
	Lee et al., "New Polycrystalline Silicon TFT's with Selectively Doped Region in the Channel", IDW '99 Proceedings of the Sixth International Display Workshops, December 1-3, 1999, pp. 1097-1098

Examiner

Ahmed N. Sefer

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4-12-01

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